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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Toshimitsu Taniguchi et al. Art Unit : 2811  
 Serial No. : 10/806,610 Examiner : Samuel A. Gebremariam  
 Filed : March 23, 2004  
 Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING  
 THEREOF

**Mail Stop Amendment**  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JUNE 2, 2005

Please amend the above-identified application as follows:

## CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

September 6, 2005

Date of Deposit

Rose Sydow

Signature

Rose Sydow

Typed or Printed Name of Person Signing Certificate